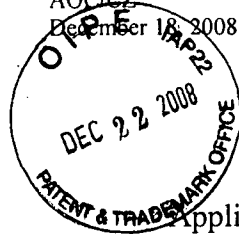


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December 18, 2008



1F AF  
PATENT APPLICATION  
Attorney's Docket No.: 3194.1019-009  
Expedited Procedure under 37 CFR § 1.116  
Examining Group 1793

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Daniel Alvarez, Jr., Jeffrey J. Spiegelman, Joshua T. Cook, Tram Doan  
Nguyen, Daniel A. Lev and Troy B. Scoggins

Application No.: 10/565,353                      Group: 1793

Filed: March 23, 2006                      Examiner: Vanoy, Timothy C.

Confirmation No: 5574

For: HYDRIDE GAS PURIFICATION FOR THE SEMICONDUCTOR  
INDUSTRY

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<u>Anne Amison</u> Typed or printed name of person signing certificate	

**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR § 1.116**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This Amendment After Final Rejection is being filed in response to the Final Office Action mailed from the U.S. Patent and Trademark Office on October 2, 2008, in the above-identified application. Reconsideration and further examination are requested.

A Notice of Appeal from the Final Office Action dated October 2, 2008, with appropriate fees, is being filed concurrently.

Please amend the application as follows:

OK TO ENTER: /T.V./